

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/449,025
Priority Filing Date November 24, 1999
Inventor Shozo Nagano et al.
Assignee Honeywell International, Inc.
Priority Group Art Unit 1775
Examiner Unknown
Attorney's Docket No. 30-5000-(4015)-Div3
Title: Physical Vapor Deposition Target

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C.7.
7/23/01

PRELIMINARY AMENDMENT

To: Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells, St. John, Roberts, Gregory & Matkin P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3817

Sir:

Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS

In the Title

^{A1} Please replace the title with the following: --PHYSICAL VAPOR
DEPOSITION TARGET.--

In The Specification

At page 1 before the "Technical Field" section, please insert the following:

RELATED PATENT DATA

This patent resulted from a divisional application of U.S. Patent
Application Serial No. 09/449,025, filed November 24, 1999, entitled "Physical

EL465854344US

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